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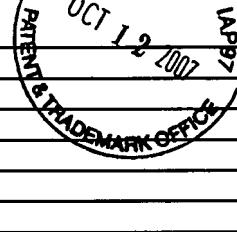
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				Application Number	10/594,317
				Filing Date	September 27, 2006
				First Named Inventor	Akira UMEDA
				Art Unit	
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	04208.0245-00000

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS

Examiner Initials	Cite No.	Document Number Number-Kind Code (if known)	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Foreign Patent Document Country Code Number Kind Code (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation
		JP 06-331647	12/2/1994	Yamada KEIZO		English Abstract
		JP 07-242112	9/19/1995	Mizutani JUNJI et al.		English Abstract
		JP 09-043269	2/14/1997	Morita YOSHIYUKI et al.		English Abstract
		JP 2000-356647	12/26/2000	Sasaki TOSHIYUKI et al.		English Abstract
		JP 2003-101033	4/4/2003	Saito MASAKATSU et al.		English Abstract
		JP 2004-093552	3/25/2004	Sakaguchi ISAO		English Abstract

NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation
		Alan LAI et al. "Semi-automatic calibration technique using six inertial frames of reference," PROCEEDINGS OF SPIE, Vol. 5274, pages 531-542, 2003	
		W. H. Press, S. A. Teukolsky, W. T. Vetterling and B. P. Flannery, Numerical Recipes in C, Second Edition, Cambridge University Press, USA, 1992, pp. 32-104	
		W. H. Press, S. A. Teukolsky, W. T. Vetterling and B. P. Flannery, Numerical Recipes in C, Second Edition, Cambridge University Press, USA, 1992, pp. 394-455	

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